Ion Feedback Suppression with MHSPs

(not entirely new ideas, originally developed for gas photomultipliers)

LCTPC Collaboration Meeting, March 26. 2012 R. Diener, DESY





MHSP Ion Suppresion Definition



• Ion back flow:

 $\mathsf{IBF} = (\mathsf{I}_{\mathsf{C}} \mathsf{-} \mathsf{I}_{\mathsf{PI}}) / \mathsf{I}_{\mathsf{A}}$

- I_c : cathode current
- $\mathbf{I}_{_{\mathrm{Pl}}}$: primary ionization current
- I_A : anode current





 Micro-Hole & Strip Plates (MHSP): One side of a GEM with additional strips that can be run independently at different potential than the rest of the GEM



- Original idea: do additional amplification after the GEM hole
- Then: Reverse-bias to collect ions from previous amplif. stage (affects electron extraction, too!)



DESY



- Next step towards better ion collection: "Flipped" Reversed-bias Micro-Hole & Strip Plates F-R-MHSP
- Catches also ions from 1st amplification stage



Amplification setup:

- F-R-MHSP, GEM, MHSP
- 3 fold ion back-flow reduction by MHSP (closest to anode)
- F-R-MHSP on top:
 - same electron collection efficiency as normal GEM
 - 6-fold better ion back-flow suppression than GEM (2x better than R-MHSP)
- Total IBF value: ~1.5 10⁻⁴ at gain of 10⁴ (drift field as in TPC ~200V/cm)
- Translates to:
 - less than 2 ions per avalanche electron drift back (8 for R-MHSP as first element)

bottom

cathode

ind



A.V. Lyashenko et.al., 2007 JINST 2 P08004





MHSP Ion Suppresion Further Ideas



• Double sided R-MHSP



• Cobra GEMs

A.V. Lyashenko et.al., 2009 NIMA 598, P116-120

- Result from 2008:
 - better ion suppresion
 - BUT only 20% electron collection efficiency!
- Better with optimized pattern?





- Next steps:
 - Collect more information
 - CST/Garfield++ Simulations
 - Possible collaboration with TU Munich group (working on high rate TPCs) to measure properties